Plasma conductivity as a probe for ambient air admixture in an atmospheric pressure plasma jet

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Abstract

By utilizing a fully floating double electrical probe system, the conductivity of a linear atmospheric pressure plasma jet (APPJ), utilizing nitrogen as process gas, was measured. The floating probe makes it possible to measure currents in the nanoamp range, in an environment where capacitive coupling of the probes to the powered electrodes is on the order of several kilovolts. Using a chemical kinetic model, the production of reactive nitrogen oxide and hydrogen-containing species through admixture of ambient humid air is determined and compared to the measured gas conductivity. The chemical kinetic model predicts an enhanced diffusion coefficient for admixture of O₂ and H_2O from ambient air of 2.7 cm²s⁻¹, compared to a literature value of 0.21 cm²s⁻¹, which is attributed to rapid mixing between the plasma jets and the surrounding air. The dominant charge carriers contributing to the conductivity, aside from electrons, are NO⁺, NO₂⁻ and NO₃⁻. Upon admixture of O₂ and H₂O, the dominant neutral products formed in the N₂ plasma jet are O, NO and N₂O, while $O_2(^{1}\Delta_g)$ singlet oxygen is the only dominant excited species.

1. Introduction

Atmospheric Pressure Plasma Jets (APPJ's) have a large potential for cost efficient in-line surface modification, without the need for expensive and bulky vacuum equipment [1–4]. Moreover, jets can be used to treat complicated geometries, allowing for a wider range of applications than possible within the confines of a vacuum chamber. Other applications of

APPJ include sterilization of medical equipment as well as plasmastimulated wound healing [5–7]. Independent of the specific application, quantitative knowledge of the charged, excited and radical species concentrations in the plasma jet is desirable. For surface modification, this entails knowing how much ambient air is admixed with the carrier gas as a function of distance to the treated surface in order to understand the effect of oxidizing agents on the surface or on the precursor molecules admixed in the jet. For both sterilization and wound healing applications, reactive and radical species such as O₃, NO, NO₂, OH and H₂O₂ as well as excited singlet oxygen $O_2(^{1}\Delta_g)$, play a role in affecting microorganisms or mammalian tissues [8]. The ability to quantify these species formed during admixture of ambient air is, therefore, highly relevant. Measuring species concentrations of molecules and electrons in an APPJ can be very challenging due to the usually small dimensions of the jet (< 1 mm) and is commonly achieved using laser diagnostics [9,10] or using atmospheric pressure mass spectrometry [11]. The system studied in this work is a double linear APPJ system utilizing nitrogen as carrier gas, the VITO PlasmaLine[®] [12]. We take full advantage of the linear design of the plasma source by applying a double electrical probe to determine electron concentration and estimate positive and negative ion concentrations in the short-lived afterglow. The resulting conductivity data is analyzed using a chemical kinetic model, providing an effective diffusion coefficient for the admixture of ambient air into the jet and quantifying the dominant Reactive Oxygen Nitrogen Species (RONS), hydrogen containing species, as well as the dominant excited and charged species.

2. Experimental setup

2.1 Plasma source

The PlasmaLine[®] source utilizes a double slit atmospheric pressure dielectric barrier discharge with gaps of 0.5 mm with a 2 mm thick quartz and mica stack on the powered electrode and a stainless steel grounded electrode, see Figure 1. The total width of the system is 20 cm, while the electrodes extend 2 cm into the source. A typical flow of 200 l/min nitrogen gas is passed through the DBD's, resulting in two parallel 20 cm wide linear plasma jets,

with an average gas flow velocity of around 7.3 m/s. The N₂ process gas is 99.999% pure, with contributions of < 3 ppm O₂ and < 2 ppm H₂O (Air Products Nitrogen Premier). A nearly sinusoidal voltage with a frequency of 55 kHz and an amplitude of up to 10 kV is applied to the electrodes using an AFS generator (G10S-V) and transformer (GT40), resulting in dissipated power densities of up to 80 W/cm³ in the discharge, as determined from IV characteristics [13]. The discharge itself is sealed off from the atmosphere by virtue of the gas flow, while the plasma jets emerging from the DBD's are exposed to the surrounding air. A schematic of the plasma source is shown in Figure 1. The setup is placed inside a ventilation cabinet with an exhaust flow of 5 m³min⁻¹. The relative humidity RH of the ambient air in the lab is ~ 50% at a temperature of 20°C. The temperature of the plasma afterglow is monitored using a fiber optic thermometer attached to the central, grounded electrode, which is expected to thermalize with the output gas stream.

The plasma jets were studied spectroscopically in [14], where it was shown that the jets are in a late afterglow phase. This indicates that the plasma jets can be described as a flowing, recombining plasma, with the N₂ DBD in the interior acting as a steady source of ions, electrons and, predominantly, atomic nitrogen. The average flow velocity through the DBD is 4 m/s, which results in a transit time of ~ 5 ms for the gas to pass over the 2 cm deep electrodes. With the 55 kHz driving voltage, this results in each N₂ molecule being exposed to ~ 280 full discharge cycles before flowing out into the jet. Because of this, the plasma jets are considered to be a continuous plasma, despite the DBD source being a transient plasma.

2.2 Flow sensor

A custom-built hot-wire (HW) anemometer flow sensor is used to determine both the effective width of the plasma jet and the gas flow velocity between 0 and 14 mm from the source exit. The device is calibrated using a well-defined flow. The flow data is used to calculate the time-of-flight of particles as a function of distance to the source exit. Both the flow sensor and the calculation of time-of-flight are treated in more detail in a previous publication [14].

2.3 Electrical probe

The custom-built double electrical probe used in this work is an electrically floating device with a built-in current readout display and voltage generator. The compact voltage generator uses a 9 V battery and a flyback DC-DC converter to apply bias voltages of up to 300 V to a probe head. The DC-DC converter operates on a period of 125 µs, which is much shorter than the RC time of the accompanying measurement circuit. This ensures that the bias voltage is effectively constant on the time-scale of the measurement. The measurement sensitivity is 0.1 nA. A completely floating system is made necessary by the strong capacitive coupling between probe heads and the high voltage electrodes of the plasma source, as well as the very low current to be measured. For the same reason, the entire device is electrically shielded and two identical probe heads are used, placed at exactly the same distance from the source, eliminating any influence of AC coupling on the measurements. With this method it is possible to measure DC currents in the nA range, in an environment where capacitive coupling to the powered electrodes is on the order of several kV's. The probe heads in contact with the jet are 2 cm long copper cylindrical wires with a diameter of 2 mm, with only the sides facing each other not covered with insulating resin. The placement of the probes is depicted schematically in Figure 1. The insulation was applied to minimize DC currents drawn from anywhere but the opposite probe. The 2 mm cylindrical probes, combined with flow velocities on the order of 2 m/s, amount to a Reynolds number of Re \approx 200, so that the jet flow profile is not significantly perturbed by the probes. Several sets of probes are used, each pair on a detachable base, with heart-to-heart probe separations of 5, 10, 15, 20 and 30 mm. For a single double probe set, an IV characteristic is obtained by manually altering the bias voltage between the probes from -300 V to +300 V in steps and measuring the resulting current via a built-in high-impedance ammeter with an LCD display. The measurement bandwidth is limited to ~ 4 ms, ensuring that any fluctuations in the discharge (which has a period of $\sim 18 \ \mu s$) are averaged out. Sufficient time is taken between each change of bias voltage to make certain the probe system and its shielding have attained their steady-state potentials.



Figure 1: Schematic cross section (left) and front view (right) of the PlasmaLine source. Indicated are high voltage electrodes (V), mica dielectric barriers (M), quartz dielectric barriers (Q), grounded central electrode (G), discharge region (d), afterglow region (a), recirculation cell (r) and the locations of the probes (P).

3. Results and discussion

3.1 Gas flow measurements

Flow profiles from 0.4 to 14 mm from the source are measured, in steps of approximately 1 mm, and combined to obtain the result depicted in Figure 2a. Since the flow sensor calibration is temperature dependent, these measurements were performed with plasma off, using only nitrogen at T_{cal} = 20 °C. With plasma on, the temperature of the gas increases by $\Delta T = 50$ °C, which leads to gas expansion and a proportionally higher flow velocities, which is taken into account by multiplying flow velocity by a factor of (T_{cal}) $+\Delta T$) / $T_{cal} = 343$ K / 293 K in the analysis of the data. The flow profiles at various distances from the source were fitted with Gaussian functions to determine FWHM, which can be equated to the width of the contact area between the jet and electrical probes, as well as the characteristic length scale over which diffusion occurs. In the region where the two jets begin to overlap (from 5 to 10 mm from source, see Figure 2a), the flow in between the two jets is not fitted by Gaussian functions and is neglected in the analysis, as this is assumed to be part of a recirculation cell (see Figure 2b). The recirculation cell is the result of a low pressure region created in between the two jets, where the shear from the jets circulates the enclosed gas, see e.g. [15]. In the recirculation cell, as well as outside the FWHM of the flow profiles, the high residence time of plasma species is assumed to be large enough to lead to a negligible density. As discussed in the supplementary information of [14], the gas flow is best described by a k- ϵ turbulent flow model. This model predicts a turbulence intensity (the ratio of velocity fluctuations to the velocity proper) of ~ 20% within the jet. Due to the resulting enhanced mixing, the concentration of species over the width (*i.e.* FWHM) of the jets is assumed to be roughly uniform at each point along the flow direction. This assumption allows for the application of a 1D chemical kinetic model to the measured data, which will be discussed further in a later section. A time-of-flight of species from the source exit is determined from the average flow velocities within the FWHM regions of the measured flow, with an error of 10% due to uncertainty in the flow velocity. In Figure 2c, the FWHM is plotted as a function of this time-of-flight, including an exponential fit of this data to obtain an interpolation of FWHM for each point along a plasma jet.



Figure 2: (a) Flow velocity as a function of position measured with the custom-built flow. The x-axis is the distance to the source while the y-axis runs parallel to the source (i.e. the vertical direction in Figure 1). The figure is an interpolation of data obtained with a resolution of approximately 1 millimeter. (b) Example of the Gaussian fits of the cross-sectional flow (red lines), excluding the recirculation zone in the center. (c) The FWHM of the Gaussian fits as a function of time-of-flight (points), including an exponential fit of these points (red line).

2.2 Double probe measurements

Typical IV characteristics obtained using the floating double probe are depicted in Figure 3 for probe separations of 5, 10 and 15 mm at a distance of 1 cm from the source. The error bars in the graphs are based on the fluctuations observed in the current at each voltage, which are on the order of 2 nA, but increase with probe separation and distance to the source.



Figure 3: Typical IV characteristics for the floating double probe with probe separations of 5, 10 and 15 mm at a distance of 1.0 cm from the source. The orientation of the probes is as depicted in Figure 1. The black lines are guides to the eye, while the red line is a fit of Equation (1) in the range of -30 V to +30 V, assuming $k_b T_e \ll eV_{bias}$.

The IV characteristics depicted in Figure 3, have an S-shape typical of a double probe measurement, which *at first glance* appears to adhere to the standard relation for double probe current i_{probe} as a function of V_{bias} [16]:

$$i_{probe}(V_{bias}) = i_{sat,0} \frac{e^{eV_{bias}/k_b T_e} - 1}{e^{eV_{bias}/k_b T_e} + 1} + s_{sat}V_{bias},$$
(1)

with e the electron charge, k_b the Boltzmann constant and T_e the electron temperature, $i_{sat,0}$ the probe saturation current at high V_{bias} extrapolated to $V_{bias} = 0$ and s_{sat} the slope of the IV characteristic in the saturation regime at high V_{bias} . Equation (1) is commonly used for probe measurements in the low-pressure regime. However, when we apply Equation (1) to the data in Figure 3, $T_e = 30$, 40 and 50 eV for probe separations of 5, 10 and 15 mm, respectively, is found. These high electron temperatures are extremely unlikely in atmospheric pressure plasma, especially considering that a previous spectroscopic study of these plasma jets revealed a recombining plasma with no evidence for high temperature electrons in the spectra [14]. Moreover, T_e should not depend on probe separation. Other authors find reasonable electron temperatures using similar electrical probe measurements on atmospheric pressure plasma jets and flames, though the process gas is either He, Ar or a methane/oxygen mixture at high gas temperature [17–19], with Klagge and Tichý finding errors in T_e no greater than 20% at atmospheric pressures [20]. Osaka et al. find a linear IV characteristic in methane/oxygen mixtures with V_{bias} in the range \pm 90 V, similar to what is seen here [21]. We suggest that the actual double probe characteristic is lost within the noise around $V_{bias} = 0$, as was also suggested by Wild *et al.* regarding the results of Osaka *et al.* [18]. This implies that T_e is too low to be determined from the probe characteristic at our current measurement sensitivity. The saturation in probe current observed in Figure 3 for $|V_{bias}| > 30$ V is likely due to the draining of charged particles from the plasma between the probes, accounting for the weaker saturation seen with increasing probe separation. As will be determined later, charged particle densities at the probe locations are $< 5 \cdot 10^9$ cm⁻³, which, with flow velocities on the order of 1 m/s and jet cross-sectional areas of ~ 50 mm², provide a flux of charged particles of < 30 nA to the area between the two probes. Once the probes begin to draw more current than is supplied by the gas flow, saturation sets in. This effect is not accounted for by Equation (1). The slope observed for $|V_{bias}| < 30$ V can, however, be identified as s_{sat} in Equation (1), assuming $k_b T_e \ll eV_{bias}$, and is related to the conductivity of the plasma between the probes. This allows us to treat the plasma between the probes as a series of resistors, from which ion and electron densities in the plasma jets can be derived. However, some effort must be taken to remove the influence of the plasma sheaths around the probes:

$$R_{total} = 1/s_{sat} = R_{sheaths} + R_{plasma} = R_{sheaths} + \frac{1}{\sigma_{plasma}} \frac{\Delta d_{probes} - \Delta d_{sheaths}}{A_{probes}},$$
(3)

where R_{total} is the total impedance, consisting of the impedance of the plasma sheaths around the probes $R_{sheaths}$ and the impedance of the undisturbed plasma between the probes R_{plasma} . The latter depends on the plasma conductivity σ_{plasma} , the distance between the probes Δd_{probes} , the total width of the plasma sheaths $\Delta d_{sheaths}$ and the contact area A_{probes} between the probes and the plasma.



Figure 4: Impedance measured as a function of probe separation at different distances from the source, determined from voltages between -30 and +30 V. The slopes of the fitted lines are a measure of the charge density at different positions in the plasma jets.

The impedance R_{total} , or $1/s_{sat}$, is determined for different probe separations between $V_{bias} = -30$ V to +30 V for several distances from the source, see Figure 4. Measurements cannot be performed within 5.5 mm from the source, because discharging from the HV electrodes to the probe heads occurs within this distance. Within the measurement error, the data in Figure 4 shows a linear increase of impedance with probe separation, consistent with Equation (3). According to Equation (3), the slope is equivalent to 1 / $\sigma_{plasma}A_{probes}$. The contact area A_{probes} is given by twice (for both jets) the FWHM at the relevant position in the flow (see Figure 2c), multiplied by the probe diameter of 2 mm. The conductivities σ_{plasma} are plotted as a function of time-of-flight of species in the jets in Figure 5. To relate the conductivity values to electron and ion density the relation

$$\sigma_{plasma}(t) = e\left(\mu_e n_e(t) + \sum_i \mu_i n_i(t)\right)$$
(4)

is used, with e the electron charge, n_e the electron concentration, μ_e the electron mobility at the relevant electric field strength, and μ_i and n_i the negative or positive ion mobilities or concentrations of species *i*, respectively. The maximum field strength for the undisturbed plasma can be estimated from the data at 14 mm from the source in Figure 4. Here, at 5 mm probe separation, the total impedance is ~ 6 G Ω , compared to 4 G Ω at the intercept, which should correspond to the highest observed ratio R_{plasma} / $R_{sheaths}$. The value of the impedance at the intercept can be used as a measure of the sheath impedances $R_{sheaths}$, assuming the sheaths are no wider than a few tenths of millimeters [22,23]. Since the current must be constant between the probes, a straightforward calculation using ohm's law shows that, at $V_{bias} = 30$ V, a voltage drop of at most 10 V occurs over the undisturbed plasma between the sheaths, leading to a reduced electric field strength E/n < 80 mTd. Under these conditions, μ_e has a constant value of 10^4 cm²/Vs at 350 K [24], which is consistent with the linear behavior of the resistivity with probe separation in Figure 4. Considering this low E/n, the probes will not significantly heat the electron gas between the probes. The mobilities μ_i of nitrogen, oxygen or nitrogen-oxygen ion species are on the order of 2 cm²/Vs and will therefore dominate the plasma conductivity only under conditions of high electron attachment [25–28]. In the following section, a chemical kinetic model is used to determine the contributions of electrons and ions to the conductivity.



Figure 5: Double log plot of conductivity as a function of drift time in the plasma jet. Calculated conductivities for three different diffusion coefficients D are shown for comparison.

3.2 Chemical kinetic model

The 1D convection-reaction model was previously used in [14] and is applied here with some modifications. The main difference between [14] and the model presented here, is that previously it was used to describe the development of species along a single streamline, while here it describes the species concentrations averaged across the entire FWHM of the jet. The model contains 380 chemical reactions and 59 species, where for each species the governing continuity equation is given by:

$$\frac{\partial n_x(t)}{\partial t} = \sum_i k_i \prod_j n_{j,i}(t) + S_x(t) .$$
(5)

In this equation t is time-of-flight, $n_x(t)$ the concentration of the species x in units of cm⁻³, k_i a reaction rate coefficient leading to either creation or destruction of species x in units of s⁻¹, cm³s⁻¹ or cm⁶s⁻¹, depending on the order of the reaction, $n_{j,i}(t)$ the concentration of species j involved in reaction i and $S_x(t)$ a time-dependent source term for species x in units of cm⁻³s⁻¹. The only source terms included are $S_{O_2}(t)$ and $S_{H_2O}(t)$ for O₂ and H₂O, respectively, with the forms:

$$S_{O_2}(t) = \frac{D}{l^2} \left(n_{O_2}(t) - 0.21 \cdot M \right), \tag{6}$$

$$S_{\rm H,0}(t) = 0.074 \cdot S_{\rm O_2}(t) \,. \tag{7}$$

Equation (6) is based on Fickian diffusion of oxygen from the ambient air into the volume of the jet, with *D* an effective diffusion coefficient in cm²s⁻¹, *M* the total density of all species in the jet in cm⁻³, and *l* a characteristic length scale over which this diffusion occurs, which is set equal to the FWHM of the jet as depicted in Figure 2c. The relative proportion $S_{H_2O}/S_{O_2} \approx$ 0.074 in Equation (7) corresponds to the conditions of the ambient air in the lab, with RH \approx 50% at 20°C. In this manner, mixing of ambient air with the plasma jet is modeled. The diffusion of N₂ from the plasma jet to the ambient is neglected, since this exchange is implicitly covered by the diffusion of O₂. Diffusion of species produced in the plasma jet to the ambient is also neglected, which is justified by the relatively high Péclet number (*l*·*v*/*D* > 10) for advective transport in the direction of the flow.

Equations (5)-(7) are solved for all 59 species, which are listed in Table 1. A constant gas temperature T_g of 330 K is assumed throughout, which is the steady-state temperature of the central electrode during operation. Electrons are assumed to be cold, with $T_e = T_g$, so that electron impact reactions are

neglected. Increasing T_e has a minor effect on the model results, leading only to slightly slower attachment of electrons over time. The initial concentration of $N_2(A)$ in the discharge is taken from literature values for N_2 DBDs and is set to 10^{15} cm⁻³ [29–31]. The initial electron/ion concentration n_e at the source exit is set at 10^{13} cm⁻³. This value does not affect the solutions to the model due to fast recombination during the first 100 µs of drift time in the jet; *i.e.* any initial electron/ion concentration > 10^{11} cm⁻³ leads to the same result for time-of-flight in excess of 100 µs. The initial atomic nitrogen concentration, which drives most of the chemistry in the plasma jet, was measured in [14] and is set at $4.2 \cdot 10^{16}$ cm⁻³. The total species concentration M is $2.2 \cdot 10^{19}$ cm⁻³, which remains constant to within 10 ppm throughout the time frame of the calculation. As can be seen in the schematic of Figure 1, the high voltage electrodes of the DBD do not extend towards the source exit but are receded by at least 1 mm. In terms of timeof-flight, the plasma has been decaying for an average of 300 µs before the starting point of the jet measurements. The initial conditions for the modeled species are therefore set at $t = -300 \,\mu\text{s}$, as listed in Table 1, including the O₂ and H₂O impurities in the N₂ carrier gas.

Table 1: Species considered in the 1D chemical kinetic model. The top row shows all species for which a non-zero initial value is used at $t = -300 \mu s$ from the source exit.

Species	Ν	O ₂	H ₂ O	N_2	N ₂ (A	e	N_4^+
					$^{3}\Sigma_{u}^{+})$		
Initial	$4.2 \cdot 10^{1}$	$7.5 \cdot 10^{1}$	$5 \cdot 10^{1}$	$2.2 \cdot 10^{1}$	10 ¹⁵	1013	1013
value	9	3	3	9			
(cm ⁻³)							
Species	Ground state:						
(zero	O, O ₃ , NO, NO ₂ , NO ₃ , N ₂ O, N ₂ O ₅ , OH, HO ₂ , H, H ₂ , H ₂ O ₂ ,						
initial	HNO, HNO ₂ , HNO ₃						
value)	Excited: N(² D), N(² P), O(¹ D), O(¹ S), O ₂ (¹ Δ_g), O ₂ (¹ Σ_g^+), N ₂ (B ³ Π_g^+), N ₂ (C ³ Σ_u^+), N ₂ (a' ¹ Σ_u^-), NO(A ² Σ^+), NO(B ² Π)						
	Charged: N ⁺ , N ₂ ⁺ , N ₃ ⁺ , O ⁺ , O ₂ ⁺ , O ₂ ⁺ (N ₂), O ₄ ⁺ , NO ⁺ , NO ⁺ (N ₂), NO ⁺ (O ₂), NO ₂ ⁺ , N ₂ O ⁺ , H ⁺ , H ₂ ⁺ , H ₃ ⁺ , H ₂ O ⁺ , H ₃ O ⁺ , OH ⁺ , O ⁻ , O ₂ ⁻ , O ₃ ⁻ , O ₄ ⁻ , NO ⁻ NO ₂ ⁻ , NO ₃ ⁻ , H ⁻ , OH ⁻						

The only variable in the calculation is the diffusion coefficient *D*, which is varied to match the observed conductivity in Figure 5 via Equation (4). Figure 5 depicts three model results, one best fit and two extreme cases. The best fit is achieved for an effective diffusion coefficient $D = 2.7 \text{ cm}^2\text{s}^{-1}$, leading to a maximum O₂ concentration of 4.4% in the plasma jet within 6 ms from the source. This effective diffusion coefficient is more than an order of magnitude higher than the diffusion coefficient of O₂ in air of 0.21 cm²s⁻¹ [32], which is attributed to enhanced mixing of the gas flow from the source with ambient air. While the Reynolds number for the jets are low, at around Re \approx 500, the jets emanating from the slits into open air create large eddy's in the shear layers between jet and air. This effect was studied by Suresh et al, who found low Reynolds number planar jets actually result in more vigorous mixing close to the nozzle exit than is the case for high Reynolds

number jets [33]. This is confirmed when comparing with the 'laminar' diffusion coefficient of $0.21 \text{ cm}^2\text{s}^{-1}$, which results in a maximum O_2 concentration of only 0.4%, with correspondingly lower concentrations of RONS and negative ions in the jet, leaving the electrons as the dominant charge carriers. This leads to a plasma conductivity 20x higher than observed, see Figure 5. To further demonstrate the use of the plasma conductivity as a measure of the admixture of ambient air, an extremely high effective diffusion coefficient was also used, leading to a maximum O_2 concentration of 21%. As seen in Figure 5, this leads to a conductivity much lower than observed.

The concentrations of selected species calculated for $D = 2.7 \text{ cm}^2\text{s}^{-1}$ are depicted in Figure 6. In regard to neutral species, it can be seen that within 1 cm of the source N and O are the dominant radical species while NO and N_2O overtake N at ~ 1 ppm at greater distances from the source. Hydrogencontaining radicals have low concentrations at ~ 50 ppb, with OH, HNO₂ and HNO₃ radicals on the same order as O₃. The dominant positive ion is NO^+ (of which some form cluster ions with O_2 and N_2), immediately from the source exit due to fast charge exchange between N_4^+ and NO. Electrons attach quickly to the available NO_2 and NO_3 , with the latter being virtually the only carrier of negative charge at more than 1 cm from the source, despite NO₃ making up only ~ 25 ppb of the gas stream. Almost all excited species are quenched within 5 mm of the source, though a significant exchange of energy occurs towards singlet oxygen states $O_2(^{1}\Delta_g)$ and $O_2(\Sigma_g^+)$, with a long lifetime > 1 ms. The source of the Σ_g^+ singlet oxygen is via direct energy exchange between $N_2(A^3\Sigma_u^{\ +})$ and $O_2,$ while $^1\Delta_g$ singlet oxygen results from recombination of two O atoms, which themselves are primarily formed from reactions between $N_2(A^3\Sigma_u^+)$ and O_2 , with a smaller contribution from reactions between atomic N and O₂.



Figure 6: Calculated concentrations of dominant species from the chemical kinetic model as a function of time-of-flight (bottom axis) and distance from source (top axis) for (a) neutral species and (b) charged and excited species. The cluster ion concentrations $NO^+(N_2)$ and $NO^+(O_2)$ are included in NO^+ .

4. Conclusions

By utilizing a fully floating double electrical probe system, the low conductivity of a DBD plasma jet can be measured, despite the strong capacitive coupling between the high voltage electrodes of the DBD system and the probe heads. Very low DC currents on the order of tens of nanoamps can still be accurately determined in a multi-kilovolt AC environment. Instead of relying on sheath theory to interpret the double probe IV characteristic, it is possible to use variable probe separations to obtain the conductivity of the undisturbed plasma. In this way, charged species densities can be determined, while the electron temperature is too low to detect in the IV characteristic. By coupling the conductivity measurements to measured gas flow profiles and applying a 1D chemical kinetic model, the effective diffusion of ambient air into the plasma jet can be obtained. The effective diffusion coefficient is found to be $2.7 \text{ cm}^2\text{s}^{-1}$, which is more than

an order of magnitude higher than would be expected in a completely laminar flow regime and is likely the result of large scale eddy's forming in the shear layer between jet and open air near the nozzle exit. A similarly high mixing close to the nozzle exit can be expected in other plasma jet sources at relatively low Reynolds number operating in ambient air, including more common cylindrical sources. The kinetic model predicts a 4% O₂ concentration between 0.5 – 1.5 cm from the source exit and a ~1 ppm production of NO and N₂O. Even at 50% relative humidity, ambient air admixture leads to minimal OH, HNO₂ and HNO₃ production in the 50 ppb range. The ions NO⁺, NO₂⁻ and NO₃⁻ constitute almost all charged species within a few millimeters from the source exit. The single dominant excited species is ${}^{1}\Delta_{g}$ singlet O₂, which is a desirable species for e.g. plasma medical applications.

Acknowledgements

This work was funded by the European Union's FP7 NMP project 'PlasmaNice'. The authors of this work thank R. Dams, R. Rego and E. van Hoof of the Flemish Institute for Technological Research (VITO) for their technical support.

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